

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Takumi MIKAWA et al.)
Japanese Application No. 11-353104) Attn: Applications
Japanese Priority Date: December 13, 1999) Branch
For: SEMICONDUCTOR DEVICE AND)
METHOD FOR FABRICATING)
THE SAME)



INFORMATION DISCLOSURE STATEMENT

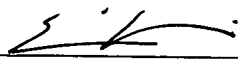
Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,



Eric J. Robinson
Registration No. 38,285

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110